

TABLE OF CONTENTS

WELCOMING ADDRESS S. Campolmi	vii
INTRODUCTORY REMARKS F. Garbassi, E. Occhiello	ix
 <u>Part I : Keynote lectures</u>	 1
 LITHOGRAPHY FOR HIGH ENERGY TECHNOLOGY IN MICROELECTRONICS J. Bargon	 3
 CROSSLINKING OF INDUSTRIAL PRODUCTS BY HIGH ENERGY ELECTRON BEAMS L. Wiesner	 19
 MODIFICATION OF SURFACE STATE OF POLYMERS BY GLOW DISCHARGE PLASMAS Y.-S. Yeh and H. Yasuda	 33
 <u>Part II : Tutorial lectures</u>	 47
 NEW FRONTIERS IN MATERIALS PROCESSING USING THERMAL PLASMA TECHNOLOGY M. I. Boulos	 49
 DEPOSITION AND ETCHING OF FLUOROPOLYMER FILMS BY PLASMA TECHNIQUE R. d'Agostino, F. Fracassi, P. Favia and F. Illuzzi	 65
 AMORPHOUS CARBON FILMS L. Martinu	 77
 MATERIALS PROCESSING WITH PULSED ELECTRON BEAM E. D'Anna, G. Leggieri, A. Luches and M. Martino	 89
 ION BEAM TREATMENT OF POLYMERS E. Occhiello, F. Garbassi	 105
 UV LASERS AND POLYMERS E. Occhiello, F. Garbassi	 115

Part III : Contributed papers

KINETIC ASPECT OF PACVD MODELING
M. Masi, M. Morbidelli and S. Carra'

ADVANCED TECHNOLOGIES FOR ULSI DEVICE PRODUCTION
G. Degiorgis and F. Illuzzi

DESIGN/OPERATING PARAMETERS OPTIMIZATION OF AN ELECTRON
ACCELERATOR FOR SURFACE TREATMENTS ON MATERIALS
THROUGH IRRADIATION
G. Matticari

CF₄/O₂ PLASMA ETCHING OF POLYMERS
E. Occhiello, M. Morra, F. Garbassi

LASER INDUCED SURFACE MODIFICATION OF POLYMERS
V. Malatesta

WETTING BEHAVIOR OF OXYGEN PLASMA TREATED PTFE
M. Morra, E. Occhiello, F. Garbassi

Author Index